

#7/AmchA
JPLS
7-18-W

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Naoya SASHIDA et al.

Serial Number: 09/321,605

Filed: May 28, 1999



Group Art Unit: 2813

Examiner: Chen, J.

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE HAVING CAPACITOR (as amended)**

A M E N D M E N T

Director of Patents and Trademarks
Washington, D.C. 20231

July 12, 2000

Dear Sir:

In response to the Office Action dated April 12, 2000, please reconsider the above-identified application amended as follows:

IN THE TITLE:

Please change the title from "SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME" to read --METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE HAVING CAPACITOR--.

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JUL 17 2000
TECHNOLOGY CENTER 2800